# LASER-INDUCED DAMAGE THRESHOLD (LIDT) MEASUREMENT REPORT 

DAMAGE CERTIFICATION (ISO 21254-3) TEST PROCEDURE

## SAMPLE: SU012564 M0074798 LOT0056696_1

## Request from

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| :--- | :--- |
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# TEST EQUIPMENT 

Test setup


## Laser and its parameters

Type
Manufacturer
Model
Central wavelength
Angle of incidence
Polarization state
Pulse repetition frequency
Spatial beam profile in target plane
Beam diameter in target plane ( $1 / \mathrm{e}^{2}$ )
Longitudinal pulse profile
Pulse duration (FWHM)
Pulse to pulse energy stability (SD)

Q-switched, seeded Nd:YAG
InnoLas Laser II
SpitLight Hybrid with OPO
2090.0 nm
45.0 deg

Linear S
100 Hz
Near Gaussian
( $169.7 \pm 0.9$ ) $\mu \mathrm{m}$
Single longitudinal mode
$(5.3 \pm 0.4) \mathrm{ns}$
$3.1 \%$

## Energy/power meter

## Manufacturer

Model
Calibration due date

Ophir
PE50-DIF-C
2020-07-01


Figure 1. Laser parameters used for measurements.

# TEST SPECIFICATION 

## Definitions and test description

Laser-induced damage (LID) is defined as any permanent laser radiation induced change in the characteristics of the surface/bulk of the specimen which can be observed by an inspection technique and at a sensitivity related to the intended operation of the product concerned. Laser-induced damage threshold (LIDT) is defined as the highest quantity of laser radiation incident upon the optical component for which the extrapolated probability of damage is zero. ${ }^{1}$

Fluence handling capability of the sample is investigated by performing a standardized test procedure. ${ }^{2}$

Test sites

| Assurance value | $\mathrm{J} / \mathrm{cm}^{2}$ |
| :--- | :--- |
| Number of sites | 119 |
| Arrangement of sites | Hexagonal |
| Minimum distance between sites | $600 \mu \mathrm{~m}$ |
| Maximum pulses per site | 1000 |

Damage detection

| Online | Scattered light diode |
| :--- | :--- |
| Offline | Nomarski microscope |

Test environment

| Environment | Air |
| :--- | :--- |
| Cleanroom class (ISO 14644-1) | ISO7 |
| Pressure | 1 bar |
| Temperature | 24 C |
| Humidity | $36 \%$ |
| Sample preparation |  |
| Storage before test | Normal laboratory conditions |
| Dust blow-off | None |
| Cleaning | Isopropanol |

${ }^{1}$ ISO 21254-1:2011: Lasers and laser-related equipment - Test methods for laser-induced damage threshold - Part 1: Definitions and general principles, International Organization for Standardization, Geneva, Switzerland (2011)
${ }^{2}$ ISO 21254-3:2011: Lasers and laser-related equipment - Test methods for laser-induced damage threshold - Part 3: Assurance of laser power (energy) handling capabilities, International Organization for Standardization, Geneva, Switzerland (2011)

## LIDT TEST RESULTS

## FLUENCE HANDLING CAPABILITY

Table 1: Fluence handling capability of sample SU012564 M0074798 LOT0056696_1.

| Fluence | Pulses | Result |
| :---: | :---: | :--- |
| $(17.2 \pm 1.2) \mathrm{J} / \mathrm{cm}^{2}$ | 1000 | Passed |
| $(23.6 \pm 1.6) \mathrm{J} / \mathrm{cm}^{2}$ <br> $($ scaled to 10 ns$)$ | Passed |  |

## TECHNICAL NOTES

## TECHNICAL NOTE 1: Oblique incidence

According to the ISO 21254-2:2011 standard, for spatial beam profiling perpendicular to the direction of beam propagation and angles of incidence differing from 0 degrees, the cosine of the angle of incidence is included in the calculation of the effective area, which leads to correct evaluation of laser fluence at different angles of incidence (Figure 2).


Figure 2. Oblique incidence.

